

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Toyokazu FUJII, et al. :
Serial No.: :
(Divisional of Serial No. 09/018,181) : Group Art Unit:
Filed: March 28, 2000 : Examiner: :
For: SEMICONDUCTOR DEVICE AND PROCESS FOR FABRICATION OF THE SAME

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

Prior to examination of the above-referenced application, please amend the application as follows:

IN THE SPECIFICATION:

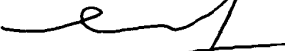
Page 31, line 15, please replace "film 6" with --film 5--.

REMARKS

The above preliminary amendment is necessary to incorporate the changes made in parent application Serial No. 09/018,181. Entry of this preliminary amendment is respectfully requested.

Respectfully submitted,

MCDERMOTT, WILL & EMERY



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